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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re the Application of: **WATANABE, Kenichi**

Group Art Unit: **2815**

Serial No.: **10/050,171**

Examiner: **WARREN, Matthew E.**

Filed: **January 18, 2002**

P.T.O. Confirmation No.: **7623**

**FOR: SEMICONDUCTOR DEVICE CAPABLE OF SUPPRESSING CURRENT CONCENTRATION IN PAD AND ITS MANUFACTURE METHOD**

**AMENDMENT UNDER 37 CFR §1.111**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

August 30, 2005

Sir:

In response to the Office Action dated **June 29, 2005**, please amend the above-identified application as follows:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 10 of this paper.